

**INFORMATION DISCLOSURE  
CITATION**

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APPLICANT

WARD-CLOSE et al

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GROUP

1793

(Use several sheets if necessary)

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

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DOCUMENT			DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
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		2 359 564	8/2001	GB				
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	Mac Rae, "Plasma ARC Process System Reactors and Applications". Plasma Chemistry and Plasma Processing, Plenum Press, New York, 9(1) SUPPL:85S-118 (1989)
	Bomberger, "The melting of titanium", Journal of Metals – JOM, Metallurgical Society of the Aime, New York 36(12):39-47 (1984)
	Patent Abstracts of Japan 0124(62) (C-549) (1988)

\*Examiner

/Christopher Kessler/

Date Considered

06/09/2008

Examiner	Date Considered
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Initial a this form with next communication to application.	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.K./